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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
09/874,606	06/05/2001	Stephen L. Skala	PHA 51243A	6706		
7	590 06/05/2002					
00.00.	CORPORATE PATENT COUNSEL PHILIPS ELECTRONICS NORTH AMERICA CORPORATION 580 WHITE PLAINS ROAD			EXAMINER		
580 WHITE P				IM, JUNGHWA M		
TARRYTOWN	N, NY 10591		ART UNIT	PAPER NUMBER		
			2011	-		

DATE MAILED: 06/05/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applic	ant(s)	
Offic Action Summer		09/874,606		ET AL.	W
	Offic Action Summary	Examiner	Art Un	it	<del></del>
	,	Junghwa M. Im	2811		
Period fo	• •				ress
THE I - External ferror of the control of the contr	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.1: SIX (6) MONTHS from the mailing date of this communication. In period for reply specified above is less than thirty (30) days, a reply operiod for reply is specified above, the maximum statutory period to reply within the set or extended period for reply will, by statute, reto reply within the set or extended period for reply will, by statute, eply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, howe	ever, may a reply be timely filed imum of thirty (30) days will be col SIX (6) MONTHS from the mailing become ARANDONED (35.1.5)	nsidered timely.	munication.
1)🖂	Responsive to communication(s) filed on 16 A	April 2002 .			
2a) <u></u>		is action is non-fi	nal.		
3)	Since this application is in condition for allowa			n as to the	merits is
Dispositi	closed in accordance with the practice under long of Claims	Ex parte Quayle,	1935 C.D. 11, 453 O.G.	213.	
4)🖂	Claim(s) $1-14$ is/are pending in the application				
•	4a) Of the above claim(s) is/are withdraw	vn from considera	ation.		
5)	Claim(s) is/are allowed.				
6)⊠	Claim(s) <u>1-14</u> is/are rejected.				
7)	Claim(s) is/are objected to.				
	Claim(s) are subject to restriction and/or	election requirer	nent.		
Application	on Papers				
9) 🗌 7	The specification is objected to by the Examiner				
10)□ T	he drawing(s) filed on is/are: a)□ accep	ted or b)☐ objecte	d to by the Examiner.		
	Applicant may not request that any objection to the			. ,	
11)∐ T	he proposed drawing correction filed on			e Examiner.	
	If approved, corrected drawings are required in rep		on.		
12)∐ T	he oath or declaration is objected to by the Exa	ıminer.			
Priority u	nder 35 U.S.C. §§ 119 and 120				
13) 🗌 .	Acknowledgment is made of a claim for foreign	priority under 35	U.S.C. § 119(a)-(d) or (1	<b>)</b> .	
a)[	All b) Some * c) None of:				
	1. Certified copies of the priority documents	have been receive	ved.		
2	2. Certified copies of the priority documents	have been receive	ved in Application No	·	
	3. Copies of the certified copies of the priority application from the International Burese the attached detailed Office action for a list o	eau (PCT Rule 17	7.2(a)).	National Sta	age
	cknowledgment is made of a claim for domestic	•		ovisional ar	oplication)
a)	☐ The translation of the foreign language proveknowledgment is made of a claim for domestic	isional applicatio	n has been received.	·	,p.,
Attachment(	s)				
2) Notice 3) Informa	of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PTO-948) ation Disclosure Statement(s) (PTO-1449) Paper No(s)	5) 🔲 1	nterview Summary (PTO-413) Notice of Informal Patent Appli Other:		
.S. Patent and Trace PTO-326 (Rev.		on Summary		Part of Pa	per No. 4

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### **DETAILED ACTION**

## **Claim Objections**

1. Claims 4, 9, 12 are objected to because of the following informalities:

The thickness of the diffusion barrier, 1.0 micron is within the range of the limitation over the thickness in claim 3.

Claim12 is a duplication of claim 9 and both claims depend on claim 8.

Appropriate correction is required.

### Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

3. Claim1, 2, 5, 6, 7, 8,10, 11, 14 are rejected under 35 U.S.C. 102(b) as being anticipated by U.S. Pat. No. to 5,693,565 to Camilletti et al.

Regarding claim 1, Camilletti et al. teach, in Fig. 4, a semiconductor chip having circuitry, the semiconductor chip comprising:

a metal bond pad layer (11A) over the circuitry and insulated on at least two sides by passivation material (12A);

a diffusion barrier layer (15A) over the metal bond pad; and

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a metal layer over (16A) the circuitry, the metal bond pad, the diffusion barrier layer and at least partially over the passivation material, the metal layer being configured and arranged for connecting to a wire bond and the diffusion barrier layer being constructed and arranged to mitigated inter-metallic compounds forming as a reaction to the metal layer-connecting to the wire bond (col. 8, lines 4-6 and col.8, lines 47-49).

Regarding claim 2, Camilletti et al. teach that the diffusion barrier layer includes TiN (col. 8, line 41).

Regarding claim 5, Camilletti et al. teach that a semiconductor chip is configured and arranged as a flip chip (col. 3, line 42).

Regarding claim 6, Camilletti et al. teach that the metal bond pad includes aluminum (col. 3, line 38).

Regarding claim 7, Camilletti et al. teach that the diffusion barrier layer includes TiN (col. 8, line 41).

Regarding claim 8, Camilletti et al. teach that the diffusion barrier layer is constructed and arranged to mitigate inter-metallic Al/Au compounds forming as a reaction to the metal layer connecting to the wire bond (col. 8, line 32-50).

Regarding claim 10, Camilletti et al. teach that the metal bond pad and metal layer include the same type of metal (col. 8, line 8-14).

Regarding claim 11, Camilletti et al. teach, in Fig. 4,a semiconductor chip having circuitry, the semiconductor chip comprising:

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an aluminum bond pad (11A) layer over the circuitry and insulated on at least two sides by passivation material (12A);

a diffusion barrier layer (15A), including TiN (col. 8, line 41), over the aluminum bond pad; and

a metal layer (16A) over the circuitry, the metal bond pad, the diffusion barrier layer, and at least partially over the passivation material, the metal layer being configured and arranged for connecting to a wire bond and the diffusion barrier layer being constructed and arranged to mitigated inter-metallic aluminum-based compounds forming as a reaction to the metal layer connecting to the wire bond (col. 8, lines 4-6 and col.8, lines 47-49).

Regarding claim 14, Camilletti et al. teach, in Fig.4, a semiconductor chip having circuitry, the semiconductor chip comprising:

an aluminum bond pad (11A) layer over the circuitry and insulated on at least two sides by means for electrically insulating the aluminum bond pad;

barrier means (15A), including TiN, over the aluminum bond pad; and a metal layer (16A) over the circuitry, the metal bond pad, the barrier means, and at least partially over means for electrically insulating the aluminum bond pad, the metal layer being configured and arranged for connecting to a wire bond and the diffusion barrier layer being constructed and arranged to mitigated inter-metallic aluminum-based compounds forming as a reaction to the metal layer connecting to the wire bond (col. 8, lines 4-6, and col.8, lines 47-49).

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# Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claim 3, 4, 9,12,13 are rejected under 35 U.S.C. 103(a) as being unpatentable over U.S. Pat. No. to 5,693,565 to Camilletti et al. in view of U.S. Pat. No. to 6,082,610 to Shangguan et al.

Regarding claim 3, Camilletti et al. disclose all the limitations as recited in claim 1, except the specified thickness of the diffusion barrier layer.

Shangguan et al. disclose, in Fig. 1, an aluminum bonding pad (12) with a diffusion barrier layer (14) which has a thickness at least 0.5 micron (col. 3, line 39).

It would have been obvious to one of ordinary skill in the art at the time of the invention was made to incorporate the teaching of Shangguan et al. into the device taught by Camilletti et al. since such thickness of the diffusion barrier layer will improve the stability of the device and alleviate the interaction between the metal layers.

Regarding claim 4, also in compliance with 35 U.S.C. 112, the minimum thickness of 1.0 microns for the diffusion barrier layer is within the rage of the thickness recited in claim 3.

Regarding claim 9, Camilletti et al. disclose all the limitations as recited in claim 1, except the specific thickness of the diffusion barrier layer and the metal layer.

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Shangguan et al. show, in Fig. 1, that a flip chip having an aluminum bonding pad (12) which have a diffusion barrier layer (14) with a thickness at least 0.5 micron (col. 3, line 39) and a metal layer (16) with the thickness of 3 microns at least (col. 3, line 53).

It would have been obvious to one of ordinary skill in the art at the time of the invention was made to incorporate the teaching of Shangguan et al. into the device taught by Camilletti et al. since such thickness of the diffusion barrier layer and the metal layer will improve the stability of the device and alleviate the interaction between the metal layers.

Regarding claim 13, Camilletti et al. disclose the diffusion barrier layer is constructed and arranged to mitigate inter-metallic Al/Au compounds forming as a reaction to the metal layer connecting to the wire bond (col. 8, line 32-50).

Note that claim 12 is, also in compliance with 35 U.S.C. 112, is the duplication of claim 9.

It is suggested to make appropriate correction.

### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Junghwa M. Im whose telephone number is (703) 305-3998. The examiner can normally be reached on MON.-FRI. 8:30AM-5:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on (703) 308-2772. The fax phone numbers

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for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

JMI June 3, 2002

TOM THOMAS
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800